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Rbw/A

PATENT  
Atty. File No: 83975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Satoshi Kitagawa

Serial No.: 09/696,117

Filed: October 25, 2000

For: **MARKING METHOD FOR SEMICONDUCTOR  
WAFER**

Examiner: Lisa M. Caputo

) Confirmation No. 4414

) Group Art Unit: 2876

)  
) *I hereby certify that this correspondence is  
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Mail Stop AMENDMENT, Commissioner for  
Patents, P.O. Box 1450, Alexandria, VA,  
22313-1450, on November 8, 2004*

Gerald T. Shekleton  
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AMENDMENT

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Entered  
12/7/04  
ATTN

Dear Sir:

The Office Action of August 12, 2004 has been carefully reviewed and the following amendments and remarks are made in response thereto.

Ok to enter the 11/24/04